



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 21, 2026

IGI Report Number **LG768623794**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **9.32 - 9.36 X 5.69 MM**

GRADING RESULTS

Carat Weight **3.05 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

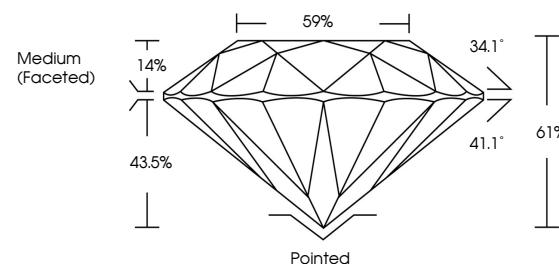
Inscription(s) **IGI LG768623794**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

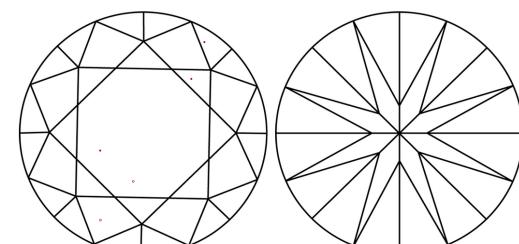
Type Ila

LG768623794
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

LABORATORY GROWN DIAMOND REPORT



January 21, 2026

IGI Report Number

LG768623794

Description **LABORATORY GROWN DIAMOND**

ROUND BRILLIANT

Shape and Cutting Style **ROUND BRILLIANT**

9.32 - 9.36 X 5.69 MM

GRADING RESULTS

3.05 CARATS

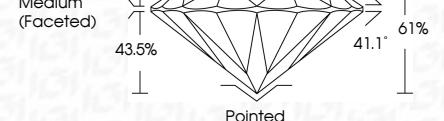
E

VVS 2

IDEAL



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
----	----	-------------------	-------------------	-------------------	------------------

Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
----------	---------------------	-----------------------------	------------------------	-------------------	----------

ADDITIONAL GRADING INFORMATION

EXCELLENT

EXCELLENT

NONE

IGI LG768623794

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type Ila



FD - 10 20



January 21, 2026

IGI Report No LG768623794

ROUND BRILLIANT

9.32 - 9.36 X 5.69 MM

3.05 CARATS

E

VVS 2

IDEAL

61%

69%

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG768623794

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type Ila